

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

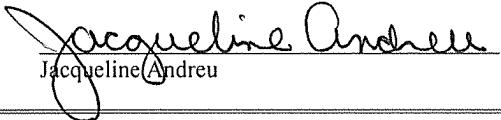
In re Application of: Eric Bornstein  
Application Serial No.: 10/649,910  
Filing Date: 26 August 2003  
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER  
SYSTEM  
Examiner: Shay, David M.  
Art Unit: 3735  
Atty. Docket No.: 072287-0019  
Confirmation No.: 5770

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**CERTIFICATE OF MAILING OR TRANSMISSION**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted (571-273-8300) to the USPTO, on the date indicated below.

Date: 25 January 2008



Jacqueline Andreu

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

This paper is in response to the Office Action dated 27 December 2007 for the above-identified application. The Applicant requests reconsideration and further examination based on the following:

- **Amendments to the Claims**, as listed in the listing of claims beginning on page 2 of this paper; and
- **Remarks**, beginning on page 4 of this paper.